On-Line Process Control Using Modular Fluidic Delivery and Fast Micro Process Gas Chromatography: From Sample Point to the DCS Connection

Sampling Platforms for the Field and Laboratory



Mike Cost – Senior Engineer Analytical Products Parker Instrumentation Products Division

Analytical Products: The Big Picture (Process/Lab)



Sample Extraction
Parker IPD/IPDE

Process analysis requires efficient control of temperature, pressure and flow at all levels of analytical architecture

Key Products:

Gen II R-MaxTM - Analysis Vent MasterTM - Pressure IntraflowTM - Heat/Pressure/Flow IntraflowTM - Gas Blending/Calibration



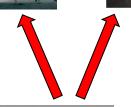




Sample Transport Heat Traced Tube Bundles







Process/On-Line

Sample Conditioning – Parker IntraFlowTM



Laboratory







Change Over System







Parker Analytical Products: Conditioning for Analysis

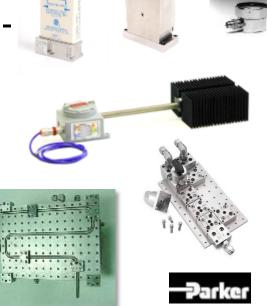
 Most important physical parameters for process/lab analytical measurement: <u>Pressure</u>, <u>Flow</u> and <u>Temperature</u>

How?

<u>Pressure Control</u> – Parker Vent MasterTM or *Intraflow*TM

Flow Control – Porter Mass Flow, Volumetric or SC423XL Flow Controllers -IntralfowTM

Temperature Control – Intertec Smart Blocktherm or Varitherm Heaters, steam or fluid flow through pegboard, Veriflo Vaporizing Regulators - *Intraflow*TM



Sampling Flow Architecture: Process and the Laboratory



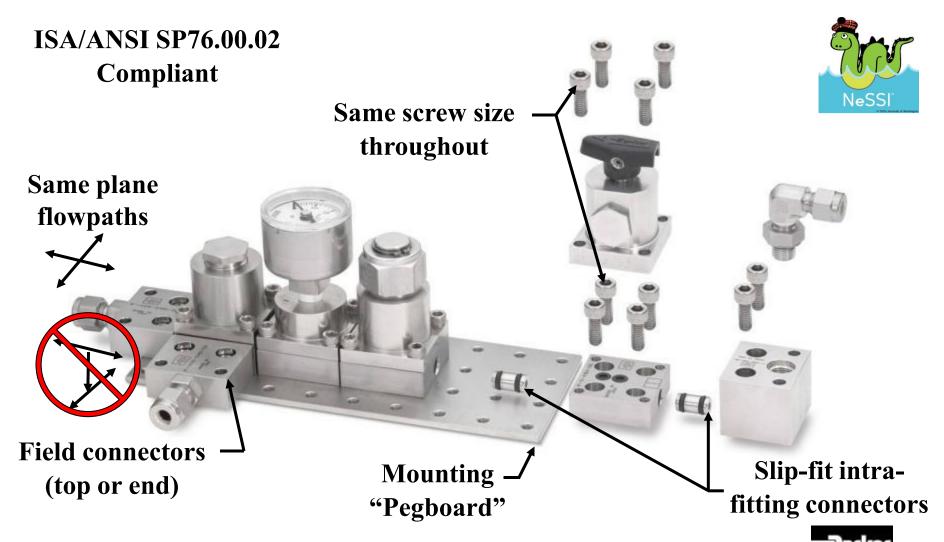






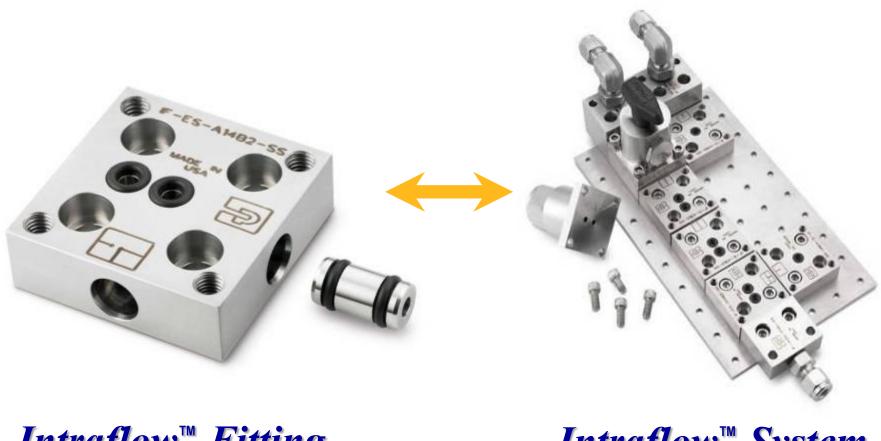


IntraflowTM Parker Modular (NeSSITM) System



Design Driver

Simplicity Overcomes Limitations



Intraflow™ Fitting

Intraflow[™] System



Design Driver

Simplicity Overcomes Limitations



Parker Tube Fitting





IntraFlow[™] Fitting



Conventional Sampling[™] System

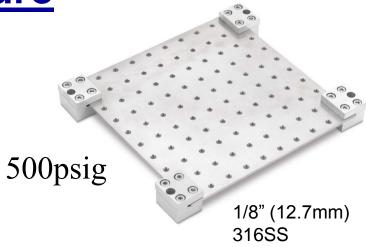


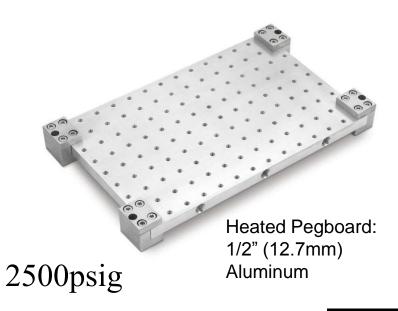
IntraFlow[™] System



Pressure & TemperatureRatings

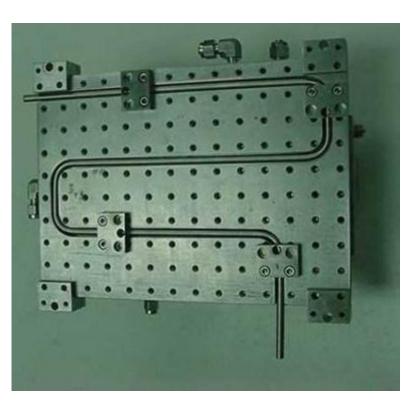
Fluorocarbon Rubber
-15°F to 400°F (-26°C to 204°C)
Buna-N Rubber
-30°F to 275°F (-34°C to 135°C)
Ethylene Propylene Rubber
-70°F to 275°F (-57°C to 135°C)
Neoprene Rubber
-45°F to 250°F (-43°C to 121°C)
Highly Fluorinated Fluorocarbon Rubber
-25°F to 200°F (-32°C to 93°C)

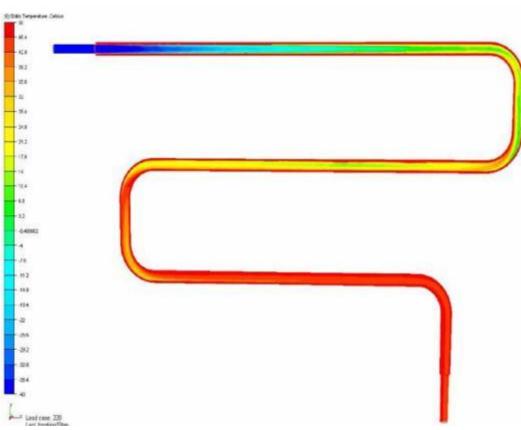






Pegboard Heating Option: Low Pressure Steam



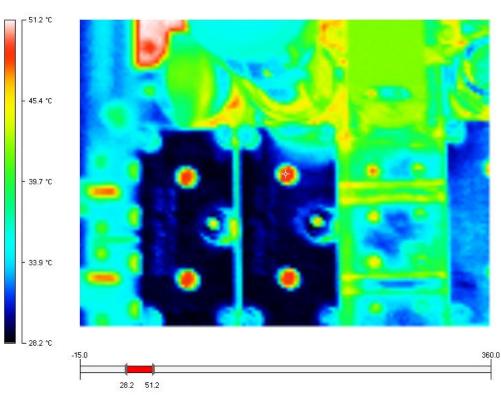


-40 C air purge supply @ 60psig / 4 bar & 20 SLPM, outlet temp 46 C



Temperature Control: Conductive Heating





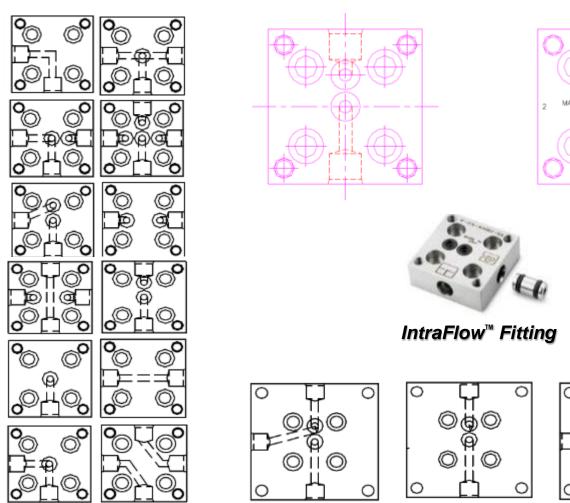
- Temperature setpoint 50^oC
- Heat transferred efficiently to components

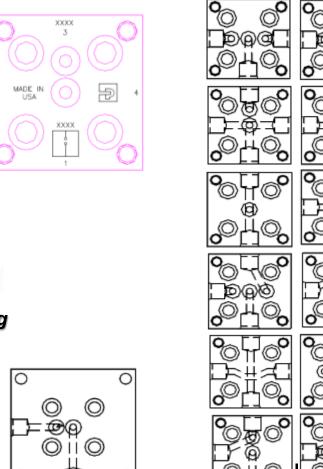


<u>Intraflow™ Substrates/Flowpath Options:</u>

The Library is Has Become Much Larger to Accommodate Laboratory and Process Applications (over 100 flow options)

Part Number Configurator/Generator



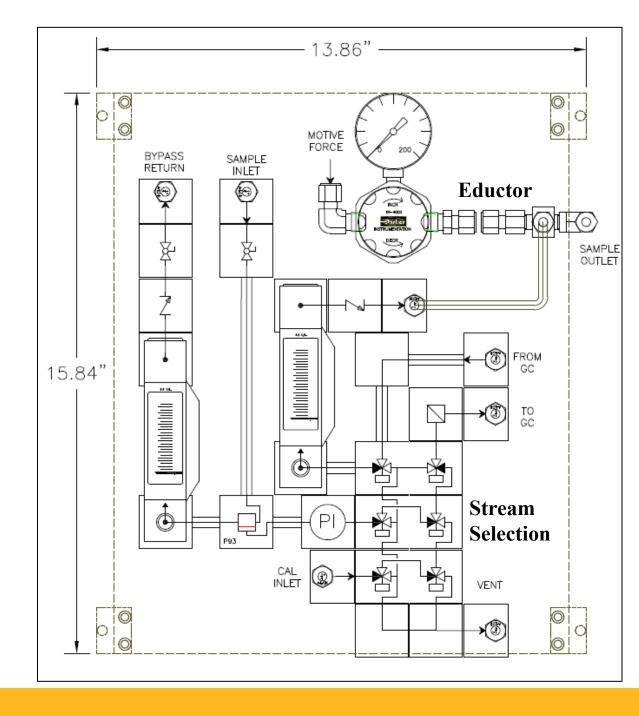


Standard of Flexibility



IntraFlow™ Fitting

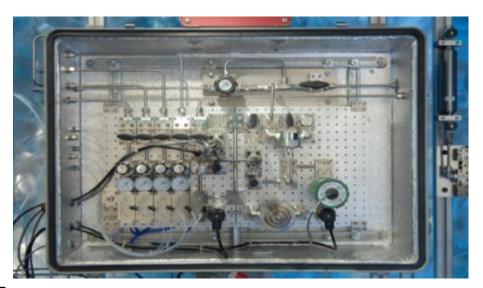
Versatility of IntraflowTM fitting allows multiple options for flow and sample conditioning



Sample System Variability Accommodated

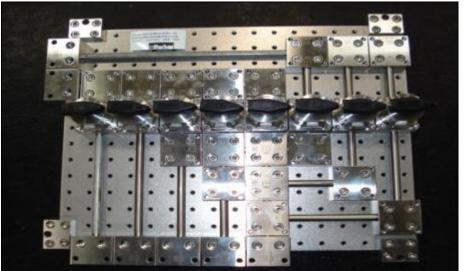
Stack Gas Monitoring:

- O₂ Analyzer
- Eductor
- Flow Monitoring
- Pressure Control/Monitoring
- Sample Stream Selection
- Remote Calibration/Validation



Manual Liquid Sample Control:

- Manual Valve Isolation
- Space Reduction
- Sample Header Implementation



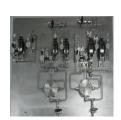


Why Modular Sampling Systems?

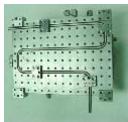
 Modularity provides greater flexibility - multiple flow path options and expansion available; customization



 Integration of traditional hardware with modular components feasible — high particulate laden samples



Superior temperature control — heating and cooling

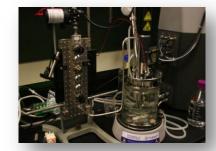


- Lower cost to operate maintenance simplified and system changes are completed with a single device
- Lower sample stream volumes micro-reactors and R&D
- Faster turnover rates close-coupled analysis



IntraflowTM: Applications Versatility

- Pump for liquid recirculation
- Fluidic control hardware
- Sensor Interface
- Temperature Control

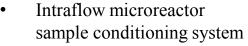






- PEEK substrate and fluidic control hardware
- RAMAN and NMR technology implemented from a single sampling platform
- Standardized platform provides ability to machine specialized sampling systems
- Sampling system allows integration of conventional hardware (i.e. pumps, analytical systems, etc.)

Normalized Standard Spectra Normalized Intensity (Arb. Units) Raman Shift (cm⁻¹)



- Analytical platform
- Provided sample introduction and purge
- **Portability**



IntraflowTM: Sampling Applications Review



IntraflowTM and MicroFast GC Analyzer Applications

Applications Detail

- Falcon Calidus GC
- Parker IntraflowTM sampling system
- Carrier gas
- Transportable
- Biotech
- Refinery



MicroGC coupled with Parker IntraflowTM Sample Conditioning System provides realization modularity concepts



IntraflowTM and Transportable Analyzer Applications

Specifications

- Falcon Analytical Process GC
- Parker IntraflowTM sampling system
- Carrier gas generation or cylinder supply
- Cart mounted for Mobility

Mobile Unit with Support Equipment Mounted - **Bring the Lab to the Field**





Biotech: Fermenter Headspace Analysis





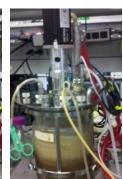


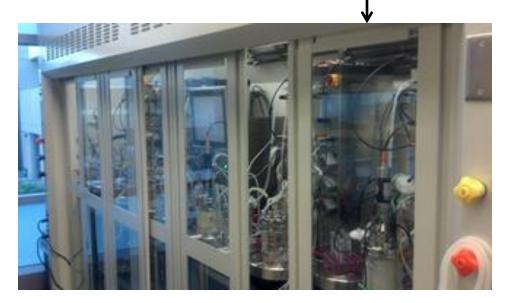










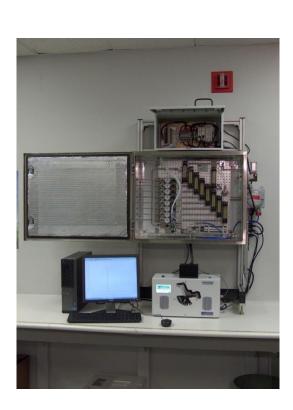


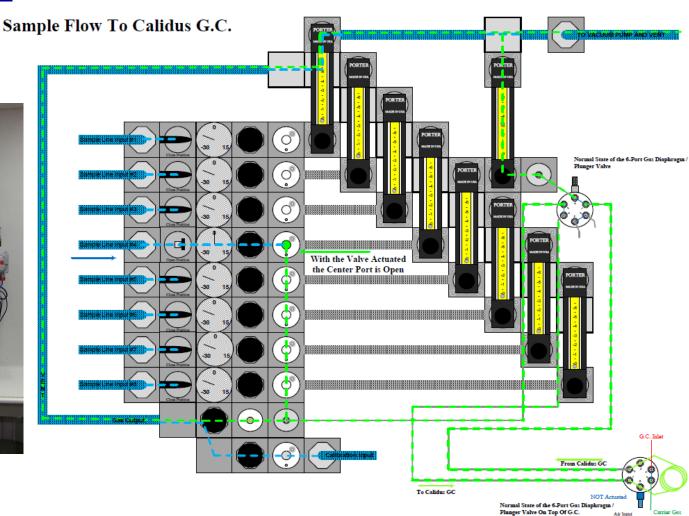
Application Overview:

- Multiple stream continuous analysis
- Space constrained area
- Atmospheric pressure sample
- Moisture laden sample



IntraflowTM and Falcon Calidus GC: Flow Architecture

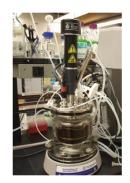




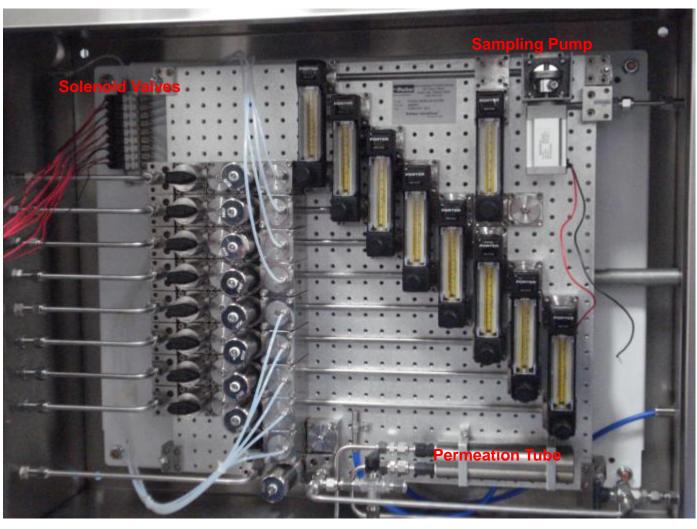


Integrated IntraflowTM Sampling System









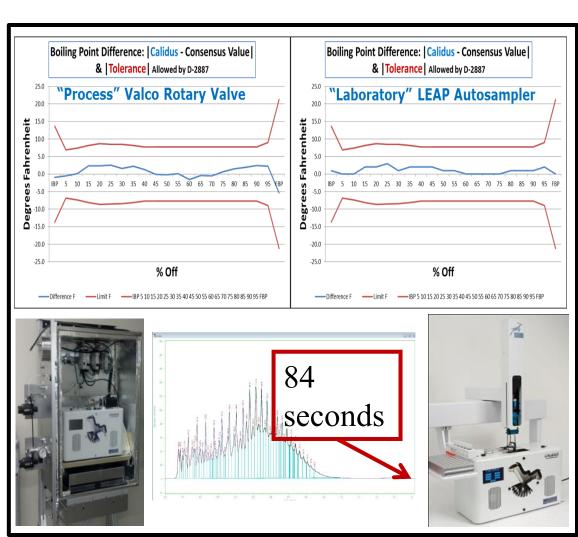
Heated Backplane 60°C



The Results Are... THE SAME regardless of installation site





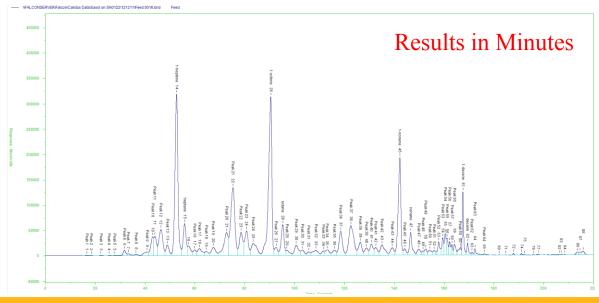


Modular Intraflow NeSSI, Modular Calidus GC, Modular Calidus Process Analyzer



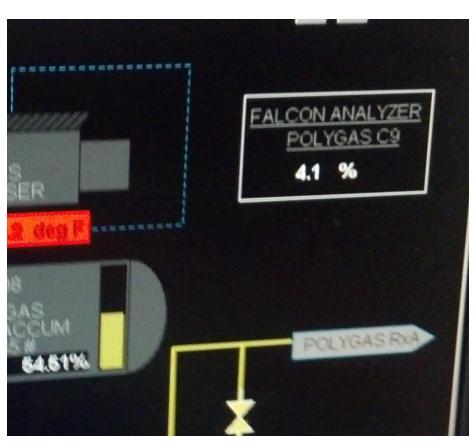






Falcon Analyzer Reporting via MODBUS to DCS

- Polygas C 9
 - Automatic report
 - 4.1%
- Notes
 - All 3 analyzers functioning beautifully
 - Realtime chromatograms on the Calidus PC screen
 - End of run reports show for every GC at run end





Analytical Products: The Big Picture (Process/Lab)



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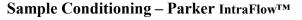




Sample Transport Heat Traced Tube Bundles



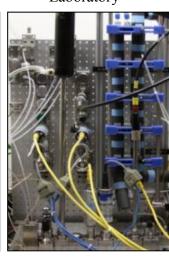




Process/On-Line















Gas Generators Change Over System



Parker Systems and Analytics: The Complete Solution















Parker – IPD: Analytical Products Installed Base





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